

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/234,233
Filing Date January 20, 1999
Inventor Weimin Li, et al
Assignee Micron Technology, Inc.
Group Art Unit 2818
Examiner D. Le
Attorney's Docket No. MI22-1035
Title: Semiconductor Processing Methods

INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449


In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patent listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

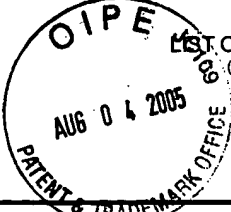
This Supplemental Information Disclosure Statement is being filed after the filing of a Request for Continued Examination (RCE) Application and prior to the receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.


Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 04 Aug 2005

By: 
James E. Lake
44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1035		SERIAL NO. 09/234,233	
 <p style="text-align: center;">LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT: Weimin Li, et al.			
				FILING DATE January 20, 1999		GROUP 2818	
U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,711,987	01/1998	Bearinger, et al.			
	AB	6,632,712 B1	10/2003	Ang, et al.			
	AC	6,790,778	09/2004	Cheng, et al.			
	AD	6,348,407	02/2002	Gupta, et al.			
	AE	5,991,217	11/1999	Tavrow, et a.			
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AJ	TW 47112A	01/2002	Taiwan			
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
EXAMINER		DATE CONSIDERED					
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U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	2005/0023691	02/2005	Watanabe, et al.			
	AB	2004/012667	07/2004	Smith, et al.			
	AC	2004/0175933	09/2004	Shishida, et al.			
	AD	2003/0173671	09/2003	Hironaga, et al.			
	AE	2003/0164354	09/2003	Hsieh, et al.			
	AF	2002/0016085	02/2002	Huang, et al.			
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
	AI						Yes No
	AJ						
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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